



Sheet 1 of 1

FORM PTO 1449 (modified)			ATTY DOCKET NO. 35.G2732	APPLICATION NO. 09/708,590			
U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE			APPLICANT MASATO MURAKI, ET AL.				
LIST OF REFERENCES CITED BY APPLICANT(S) (Use several sheets if necessary)			FILING DATE November 9, 2000	GROUP 2881			
Date Submitted to PTO: February 20, 2001							
U.S. PATENT DOCUMENTS							
*EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
KF		6,137,113	10/2000	Muraki	250	492.22	
		6,124,599	09/2000	Muraki	250	492.22	
		6,107,636	08/2000	Muraki	250	492.2	
		6,104,035	08/2000	Muraki	250	492.22	
		6,054,713	04/2000	Miyake, et al.	250	492.24	
		5,981,954	11/1999	Muraki	250	397	
		5,929,454	07/1999	Muraki, et al.	250	491.1	
KP		5,905,267	05/1999	Muraki	250	492.22	
FOREIGN PATENT DOCUMENTS							
		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION YES/NO/ OR ABSTRACT
							RECEIVED CIVIL LITIGATION CENTER FEB 22 2001
OTHER DOCUMENT(S) (Including Author, Title, Date, Pertinent Pages, Etc.)							
KF		M. Parikh, "Corrections to Proximity Effects in Electron Beam Lithography", <u>J. Appl. Phys.</u> , 50(6), June 1979, page 4371 through page 4377.					
KF		J.M. Pavkovich, "Proximity Effect Correction Calculations by the Integral Equation Approximate Solution Method", <u>J. Vac. Sci. Technol.</u> , B4(1), Jan/Feb 1986, page 159 through page 163.					
EXAMINER		DATE CONSIDERED 3-20-02					

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.